

<b>Notice of References Cited</b>	Application/Control No. 10/530,031		Applicant(s)/Patent Under Reexamination TAKAKUWA ET AL.	
	Examiner HELEN SHIBRU		Art Unit 2621	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,453,110	09-2002	Kawamura et al.	386/46
*	B	US-2005/0031311	02-2005	Bak et al.	386/095
*	C	US-6,654,031	11-2003	Ito et al.	715/723
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	K	US-			
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#### NON-PATENT DOCUMENTS

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